

Appl. No. 09/754,264
 Amendment and/or Response
 Reply to Office Action of November 19, 2004

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IN THE UNITED STATES
 PATENT AND TRADEMARK OFFICE

Appl. No.: 09/754,264

Applicant(s): Tetsuo Usami, et al.

Filed: January 5, 2001

TC/A.U.: 2800/2814

Examiner: S.H. Rao

Atty. Docket: OKI.202

Title: Deposition Method For Wiring

Thin Film

CERTIFICATE OF MAILING OR
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On: March 19, 2004By: William S. Francos
 William S. Francos

AMENDMENT and/or RESPONSE under 37 C.F.R. § 1.111

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

In response to the Office Action of November 19, 2003, please amend the
 above referenced application as follows and reconsider the application in light of the
 following remarks.

04/27/2004 TSTEPTO 00000001.500238 09754264

01 FC:1251 110.00 DA

Atty. Docket No. OKI.202

PAGE 18 * RCVD AT 3/19/2004 8:31:56 PM (Eastern Standard Time) * SVR:USPTO-EFXRF-10 * DMS:8729308 * CSID:6103758380 * DURATION (mm:ss):02:16